



3723

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Rico Cheng

Application No.: 10/045,781 (CONF-3009)

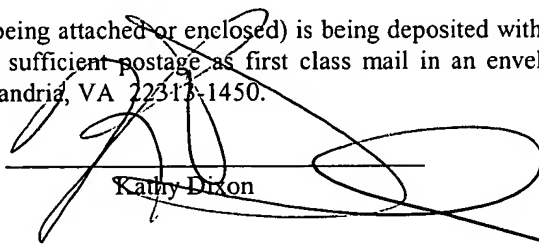
Filed: 1/12/2002

Title: Dual wafer-loss sensor and water-resistant  
sensor holder

Attorney Docket No.: 67,200-604

Group Art Unit:  
3723Examiner:  
Eziamara Anthony OjiniCommissioner for Patents  
Alexandria, VA 22313-1450**RECEIVED**  
FEB 19 2004  
TECHNOLOGY CENTER R3700Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: Feb. 11, 2004  
Kathy DixonRESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action of November 14, 2003, please amend the application as follows and consider the following remarks.